

Notice of References Cited	Application/Control No. 10/716,249	Applicant(s)/Patent Under Reexamination MENUT ET AL.	
	Examiner Howard Weiss	Art Unit 2814	Page 1 of 1

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	B	US-6,171,923	01-2001	Chi et al.	438/386
	C	US-5,543,348	08-1996	Hammerl et al.	438/249
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	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.